



FORM HDP-1449 (Based on Form PTO-1449)

**PATENT AND TRADEMARK OFFICE
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Sheet 1 of 3

ATTORNEY DOCKET NO.	SERIAL NO.
9319A-000742	10/807,920
APPLICANT	
Osamu SHINKAWA	
FILING DATE	GROUP
March 24, 2004	2861

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
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Examiner: /Brian Goldberg/

Date Considered: 06/23/2007

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Ref. Desig.	Examiner's Initials	
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2.	/BG/	Communication from China Patent Office regarding counterpart application.

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